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PATENT
Atty. Dkt. No. AMAT/4184/ETCH/CHMBRAJB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Barnes, et al.

Serial No.: 09/931,324

Confirmation No.: 3945

Filed: August 16, 2001

For: Adjustable Dual Frequency
Voltage Dividing Plasma Reactor

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1765

Examiner: Binh X. Tran

CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

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I hereby certify that the correspondence and the documents referred to as attached in the facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703/872-9311 to the attention of the named Examiner, on the date below.

August 28, 2003 Ari Haimovici

Date Signature

SECOND RESPONSE TO FINAL OFFICE ACTION DATED MAY 29, 2003

In response to the Final Office Action dated May 29, 2003, having a shortened statutory period for response set to expire on August 29, 2003, and in response to the Advisory Action dated August 8, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no fee is due in conjunction with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4184/AOP, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks/Arguments begin on page 5 of this paper.